



Semiconductor Materials Information

Gases

For Semiconductor Device Processing

A Techcet Group Critical Materials Report

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Table of Contents

	Page #
1 HIGHLIGHTS	5
1.1 Market.....	5
1.2 Supply.....	6
1.3 Suppliers.....	6
1.4 Specialty Gas Highlights	6
2 INTRODUCTION	7
2.1 Definition of Bulk and Specialty	7
2.2 Market Dynamics of 2009	7
3 THE MARKET	7
3.1 Regional Share.....	9
3.2 Supplier Market Share	10
4 TECHNOLOGY UPDATES	14
4.1 Etch Gas Trends	14
4.1.1 High Aspect Ratio (HAR) Etching	14
4.1 C-F Gas Concerns.....	16
4.2 XeF2 - Ion Implant Source Chamber Cleaning	17
4.3 XeF2 as an Etch Gas for MEMs.....	18
4.4 Xe supply Concerns.....	20
5 SHIP TO CONTROL UPDATE.....	21
6 SUPPLY ALERT	21
6.1 HCl Supply Issues	21
6.2 Helium	22
6.2.1 Helium Costs Continue to Rise.....	27
6.3 Silane	28
6.4 NF3.....	32
6.5 Shipping Logistics	34
7 ENVIRONMENTAL CONCERNS AFFECTING GAS UTILIZATION	35
7.1 Future Requirements as Outlined in the ITRS	36
7.2 PFC emissions reduction	39
7.3 Legislative Changes.....	44
7.4 Kyoto Protocol.....	44
8 GAS SUPPLIERS' PROFILES AND NEWS	45
8.1 Air Products and Chemicals (AP)	45
8.2 Air Liquide (AL)	48
8.3 Linde Group (LG).....	51
8.4 Praxair.....	52
8.5 Taiyo Nippon Sanso Corporation (TNSC)/ Matheson Tri-Gas (MTG)	54
8.6 Sodiff	56

Appendices

Appendix A: List of Abbreviations and Acronyms	57
Appendix B: Helium Source/Supply Relationships.....	61
Appendix C: Supplier Regional Market Standing	62
Appendix D: Makers and Purifiers of Selected Gases (from 2009 Report)	63
Appendix E: Future Gas Purity Requirements.....	64
Appendix E: Carbon Trading Basics	72
Appendix F: PFOS Reduction	73

Figures

Figure 1: Electronics Process Gas Market Revenues / Forecast — \$2.74 B	5
Figure 2: Electronic Gas Market Revenues	8
Figure 3: Electronic Gas Consumption Compared to MSI.....	9
Figure 4: Regional Sales — Semiconductor Process Gas Consumption (by percent volume).....	10
Figure 5: Bulk and Specialty Electronic Gas Market Shares.....	11
Figure 6: Bulk Electronic Gas Market Shares (as a % of Total Revenues).....	11
Figure 7: Specialty Electronic Gas Market Shares	12
Figure 8: Market Shares by Total Company Revenues	13
Figure 9: Typical Via Structure	15
Figure 10.: Samsung 70nm stacked capacitor structures	16
Figure 11: Comparison of Source Life With No XeF2 (Baseline) and with XeF2 Clean (AutoClean)	17
Figure 12: AutoClean Source Container for XeF2 Delivery	18
Figure 13: MEM device floating in free space on a substrate.	19
Figure 14: Helium Supply and Demand	22
Figure 15: US Helium Supply vs. Demand	24
Figure 16: US Helium Usage by Application Percent	26
Figure 17: Helium Pricing	28
Figure 18: Silane Capacity by Maker (mT)	29
Figure 19: Silane Price Trends.....	30

Figure 20: Silane WW Revenues and 2010 Forecast.....	30
Figure 21: Worldwide Silane Consumption for Electronic Applications.....	31
Figure 22: NF3 Price Declines Relative to 2000	32
Figure 23: NF3 Worldwide Revenues for Electronic Applications.....	33
Figure 24: NF3 Worldwide Consumption for Electronic Applications.....	33
Figure 25: World Semiconductor Council PFC Emissions Reductions	40
Figure A2: PFOS Mass Balance, WSC Baseline 2005.....	74

Tables

Table 1: World Production and Reserves of Helium.....	27
Table 2: Atmospheric Lifetimes and Global Working Potentials of Select Greenhouse Gases.....	35
Table 3: ITRS 2009 EHS Chemical Restrictions Table.....	38
Table 4: ESH Intrinsic Requirements from ITRS Roadmap 2009	41
Table 5. 2009 ITRS Roadmap for Chemicals and Materials Management	42
Table 6: Kyoto Protocol Greenhouse Gases List.....	44
Table A-1: Source/Supply Relationships.....	61
Table A-2: New Helium Extraction Plants	61
Table A-3: Regional Market Leaders	62
Table A-4: Producers for Selected Gases	63
Table A-5: ITRS 2007/2008 Impurity Limits for Bulk Gases; 68nm ≥ DRAM ½ pitch ≥ 25nm; 2007–2015	65
Table A-6: ITRS 2007/2008 Impurity Limits for Lithography and Critical Metrology Purge Gases (ppbv); 68nm ≥ DRAM ½ pitch ≥ 25nm; 2007–2015	67
Table A-7: ITRS 2007/2008 Impurity Limits for Specialty Gases.....	69

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